



Docket No.: 0756-7258

IFW

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re PATENT application of)
Koichiro TANAKA)
Serial No. 10/787,191) Group Art Unit: 2828
Filed: February 27, 2004) Examiner: Minsun Harvey
For: LASER IRRADIATION APPARATUS,)
LASER IRRADIATION METHOD, AND)
METHOD FOR MANUFACTURING)
SEMICONDUCTOR DEVICE)

CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with
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P. O. Box 1450, Alexandria VA 22313-1450, on July 6, 2005

Penny L. Luse

REQUEST FOR STATUS

Honorable Commissioner of Patents

P. O. Box 1450

Alexandria VA 22313-1450

Sir:

To date the undersigned attorney of record has received no action in the above-identified patent application. Please provide the undersigned with a status report of the application in writing.

Respectfully submitted,

Eric J. Robinson
Reg. No. 38,285

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